

# Search Notes



Application/Control No.

10/735,037

Examiner

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Applicant(s)/Patent under  
Reexamination

KANG ET AL.

Art Unit

2817

## SEARCHED

Class	Subclass	Date	Examiner
330	124R	2/16/2005	gl
	286		
	295		
	302		
	306		
	310		
above updated		5-18-05	gl
330	311	5-18-05	29

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
330	295	5-18-05	gl
	302		
	310		

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
EAST	2/16/2005	gl
EAST	5-18-05	gl
NPL-IEEE	5-18-05	gl